

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Patricia B. SMITH et al. Confirmation No.: 3087
Application Number : 10/647,985
Filed : August 26, 2003
Title : POST-ETCH CLEAN PROCESS FOR POROUS LOW
DIELECTRIC CONSTANT MATERIALS
TC/Art Unit : 1746
Examiner: : Zeinab El Arini

Docket No. : TI-33260
Customer No. : **23494**

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

REPLY TO OFFICE ACTION

In reply to the Office Action mailed June 28, 2007, the period for response having been extended to October 29, 2007 (the 28th being a Sunday) by a request for extension of one month and fee payment filed concurrently herewith, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims beginning on page 2 this paper.

Remarks/Arguments follow the amendment sections of this paper and begin on page 6.